



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Young-Hee MUN

Serial No.: 09/742,127

Group Art Unit: 1765

Filed: December 22, 2000

Examiner: Song, Matthew J.

For: METHOD OF TREATING SEMICONDUCTOR WAFER THERMALLY AND
SEMICONDUCTOR WAFER FABRICATED BY THE SAME

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RESPONSE TO ELECTION REQUIREMENT

Honorable Commissioner for Patent
P.O. Box 1450
Alexandria, VA 22313-1450

May 19, 2003

Sir:

In response to the Election Requirement set forth in the Office Action mailed May 9, 2003 (Paper No. 11), Applicant elects a heat treatment under a non-oxidative atmosphere. Claims 1-5, 7, 8, 17 and 19 read on the elected species.

The Examiner is respectfully requested to reconsider and withdraw the election requirement. Both 37 C.F.R. §1.141 and M.P.E.P. §806.04(a) provide that a reasonable number of species may be claimed in one application. It is respectfully submitted that the number of species claimed in the present application does not exceed such a reasonable number, particularly in view of the structural similarity of, and the similar field of search required for, the claimed species. Reconsideration and withdrawal of the election requirement, therefore, are requested.

An early Office Action on the merits is respectfully requested.

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5/21/02

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Atty. Docket No.: P66182US0

If a Petition for Extension is necessary and the petition and/or check is not enclosed, this will act as a petition to extend the time for response and authorization to charge the necessary fees under 37 CFR 1.17(a)-(d) to Deposit Account 06-1358.

Respectfully submitted,

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